## List of charges for MaSC

- O Equipments and charges are as follows, all charges include tax (10%).
- O Technical Support Center (TSC) management charges are added. 2023/4/1 (Reviewed in accordance with internal regulations: 1 area in red was changed.)

| Equipment  | Model                  | Room    | Technical Support Center (TSC) *per hour      |               |  |
|--|------------------------|---------|---|---------------|--|
|  |                        |         | Internal user<br>(other than 4<br>Institutes) | External user | Notes  |
| Scanning Electron Microscope<br>System⨯ Section Polisher                       | JSM-7800F              | room1   | 6,653   | 7,710         |  |
|  | IB-09020CP             | room1   | 4,090   | 4,288         |  |
| Field Emission Electron Probe Microanalyzer with SXES                          | JXA-8530F              | room1   | 6,388   | 7,639         |  |
|  |                        |         | 331   | 978           | Soft X-ray Spectrometer<br>Additional Charges      |
| Focused Ion Beams/Scanning<br>Electron Microscope Dual-beam<br>System(FIB/SEM) | Helios NanoLabTM 600i  | room1   | 20,844  | 22,162        |  |
|  |                        |         | 0   | 140           | Low Temperature<br>Equipment<br>Additional Charges |
| NIR Spectrometer   | NX-FLIM-T03            | room2-1 | 4,243   | 4,863         |  |
| Scanning X-ray Photoelectron<br>Spectroscopy                                   | PHI-5000 VersaProbe II | room2-2 | 9,909   | 10,399        |  |
| Multipurpose X-ray Diffraction<br>System                                       | SmartLab 3G            | room3   | 6,537   | 6,800         |  |
|  | VariMax DW with lP     | room3   | 6,849   | 7,269         |  |
|  |                        |         | 1,747   | 1,894         | Low Temperature<br>Equipment<br>Additional Charges |

<sup>\*</sup>For those who belong to MaSC Project or 4 institutes (IMR, IFS, IMRAM, RIEC), please contact the MaSC Support Office as the charge is c

O Depending on the equipment and usage conditions, additional charges for pretreatment or consumables may be required as shown below. (All prices in the table below include tax (10%).

| Carbon coater  | Carbon Deposition                   | 509 yen/time    |
|--|-------------------------------------|-----------------|
|  | DRY PUMP Operating Cost             | 5 yen/sample    |
| Cryogenic Equipment Utilization for                            | Dry column use charge               | 906 yen/time    |
| Microfabrication Systems                                       | N2 gas                              | 1, 309 yen      |
|  | Liquid Nitrogen                     | 1,054 yen       |
|  | Cu Mesh                             | 509 yen/sheet   |
|  | Mo Mesh                             | 2,750 yen/sheet |
|  | Pinstub (small)                     | 102 yen/piece   |
| Consumables for microfabrication system equipment use          | Pinstub (large)                     | 1,833 yen/piece |
| System equipment ass   | Specimen Base Tube                  | 255 yen/piece   |
|  | Pinstub Case (large)                | 2,139 yen/piece |
|  | Gel Sample Case                     | 917 yen/piece   |
| Use of 3D Image Analysis Software for Microfabrication Systems | Software and PC maintenance license | 110yen/hour     |
| Consumables for Multi-purpose                                  | Glass Capillary                     | 350 yen/piece   |
| X-crystal Structure Analysis System                            | Quartz Capillary                    | 800 yen/piece   |